

# Abstracts

## COM2 enhanced graded base SiGe technology for high speed applications (2002 Vol. I [MWSYM])

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*T. Ivanov, M. Carroll, S. Moinian, M. Mastrapasqua, A. Freij, A. Chen, C. King, A. Hamad, E. Martin, S. Shive, T. Esry, C. Lee, R. Johnson, T. Sorsch, K. Banoo, P. Smith and W. Cochran. "COM2 enhanced graded base SiGe technology for high speed applications (2002 Vol. I [MWSYM])." 2002 MTT-S International Microwave Symposium Digest 02.1 (2002 Vol. I [MWSYM]): 183-186 vol. 1.*

The COM2 enhanced graded base SiGe modular BiCMOS technology has been developed. It is based on the COM2 digital CMOS process. The technology achieves peak  $f_{\text{sub } t}/=100$  GHz, peak  $f_{\text{sub } \text{max}}/=101$  GHz, peak  $/\text{spl } \beta/=186$  and  $\text{BV}/\text{sub } \text{cex}/=2.05$  V. An  $f_{\text{sub } t}\text{-BV}/\text{sub } \text{cex}/$  product of 205 and good across wafer uniformity are demonstrated.

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